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(54) **MEMORY CONTROLLED CIRCUIT SYSTEM AND APPARATUS**

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(52) **U.S. Cl.**
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(57) **ABSTRACT**

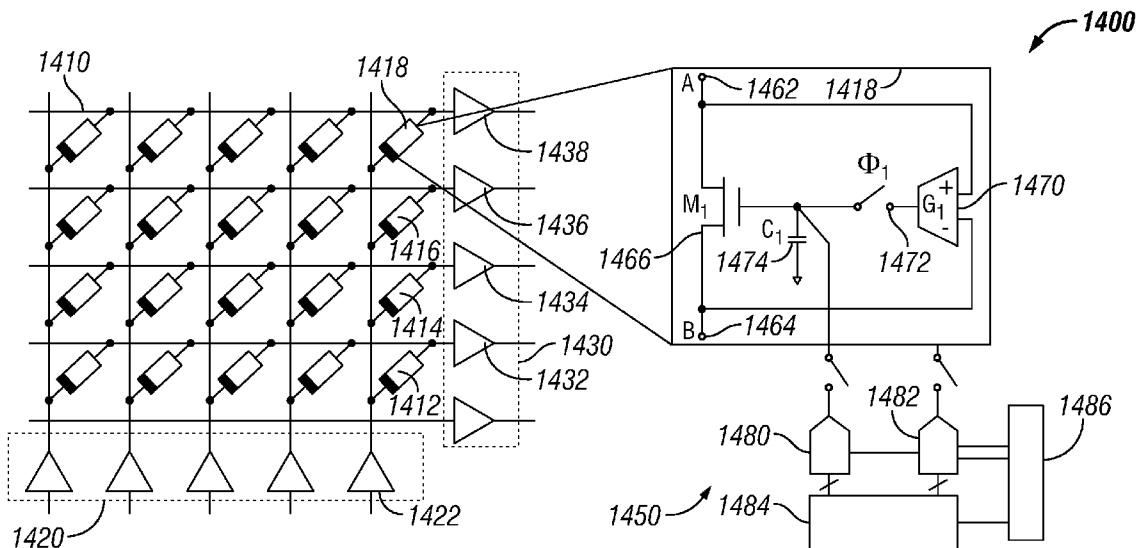
In an embodiment, a memory controlled circuit includes a configurable circuit element electrically coupled to a first terminal and to a second terminal. The memory controlled circuit further includes a weight update circuit. A first input of the weight update circuit is electrically coupled to the first terminal and a second input of the weight update circuit is electrically coupled to the second terminal. The memory controlled circuit also includes a dynamic analog memory electrically coupled to the configurable circuit element and to the weight update circuit.

Related U.S. Application Data

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Publication Classification

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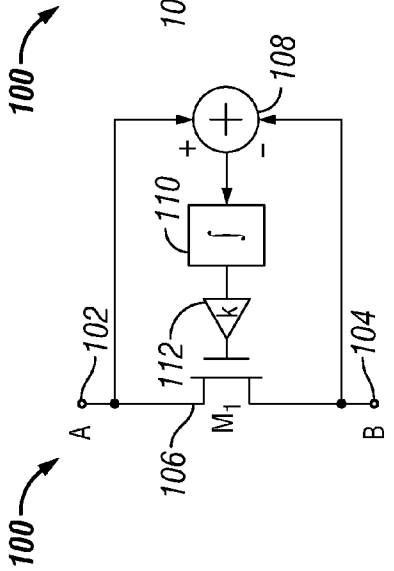


FIG. 1A

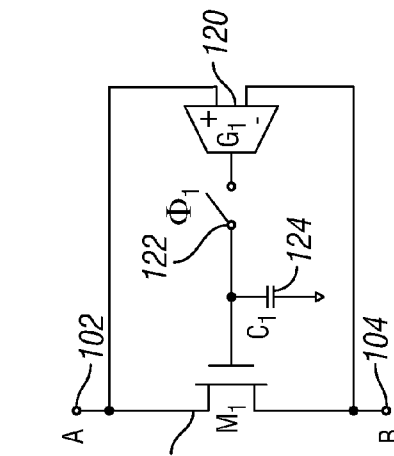


FIG. 1B

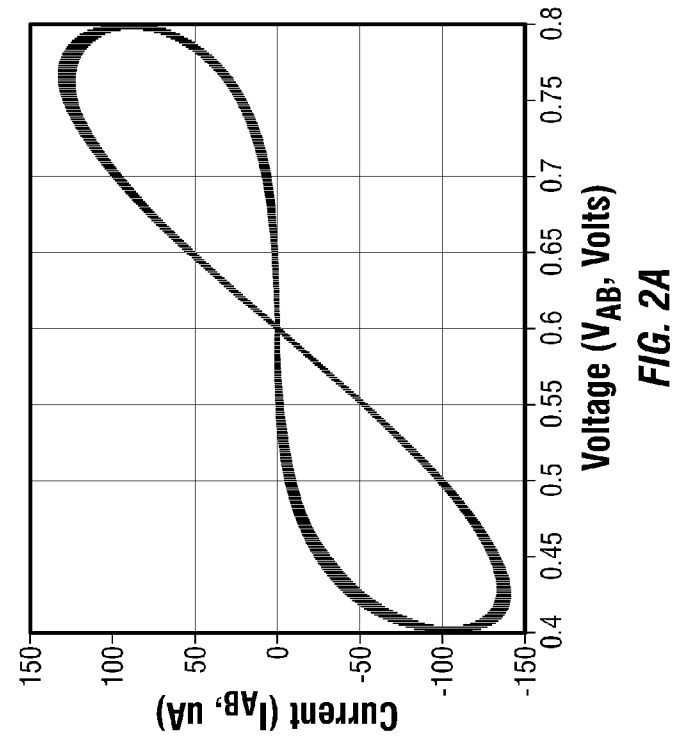


FIG. 2A

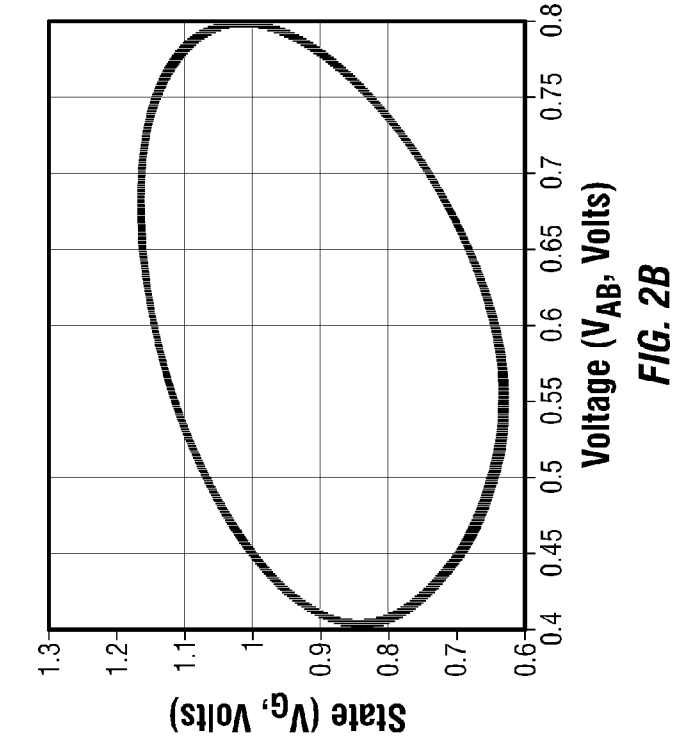


FIG. 2B

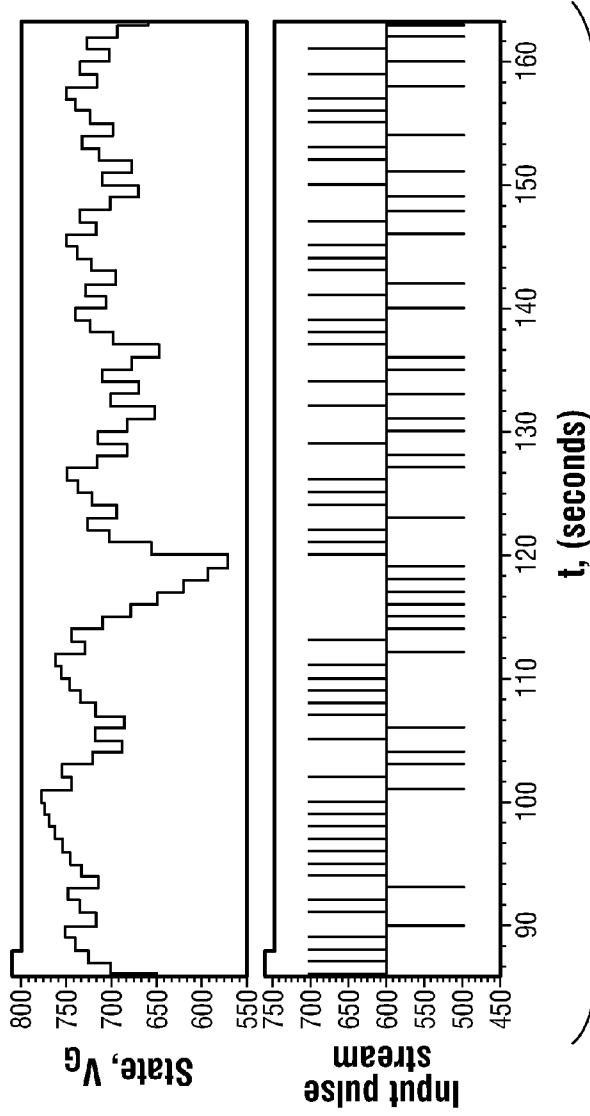


FIG. 3

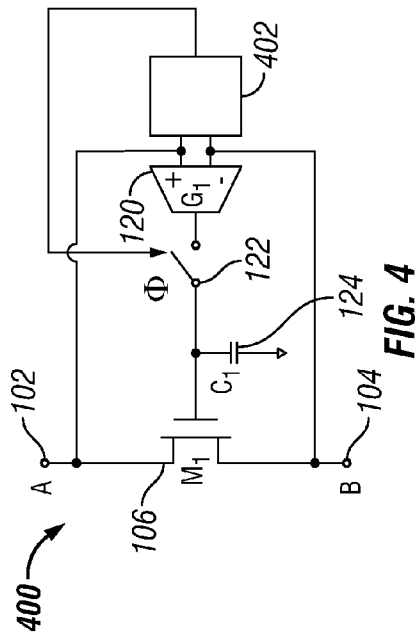


FIG. 4

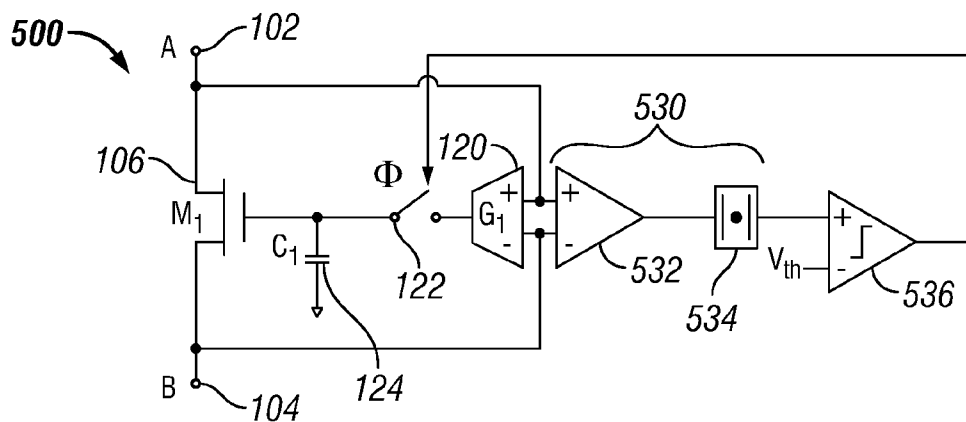


FIG. 5A

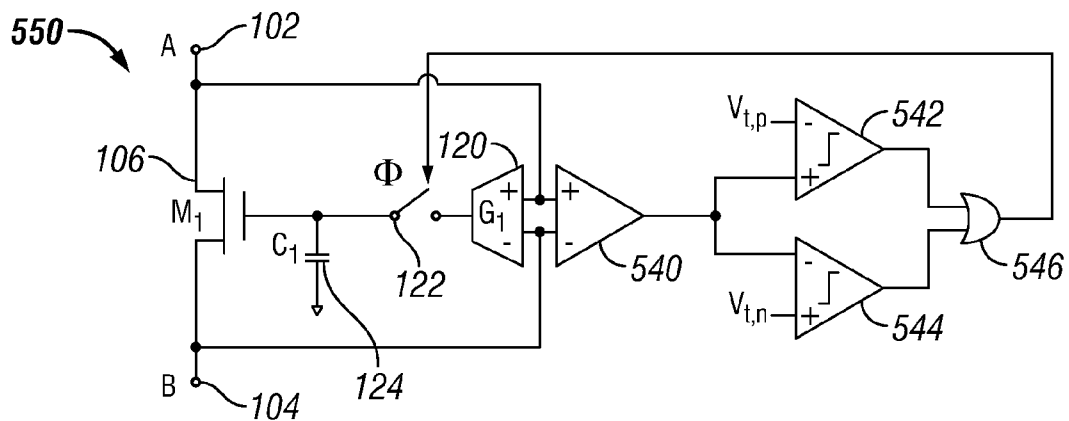


FIG. 5B

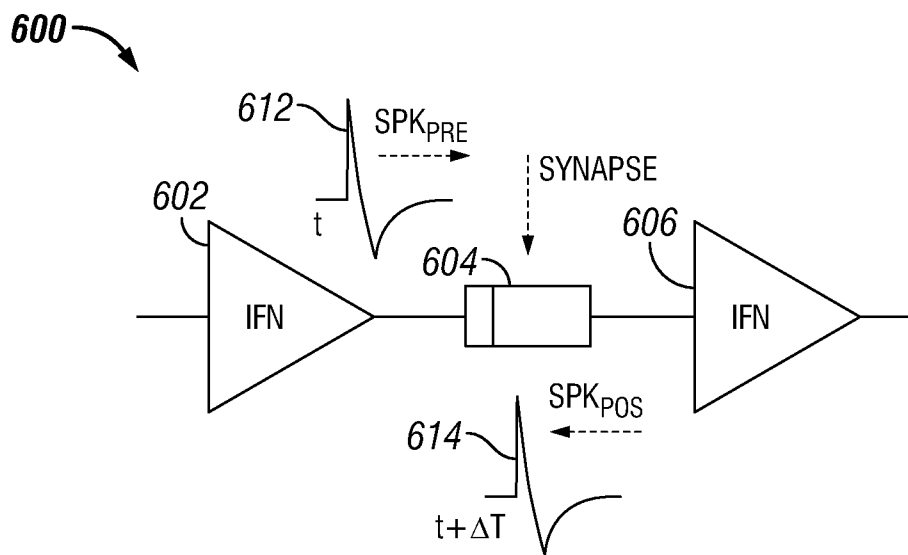


FIG. 6A

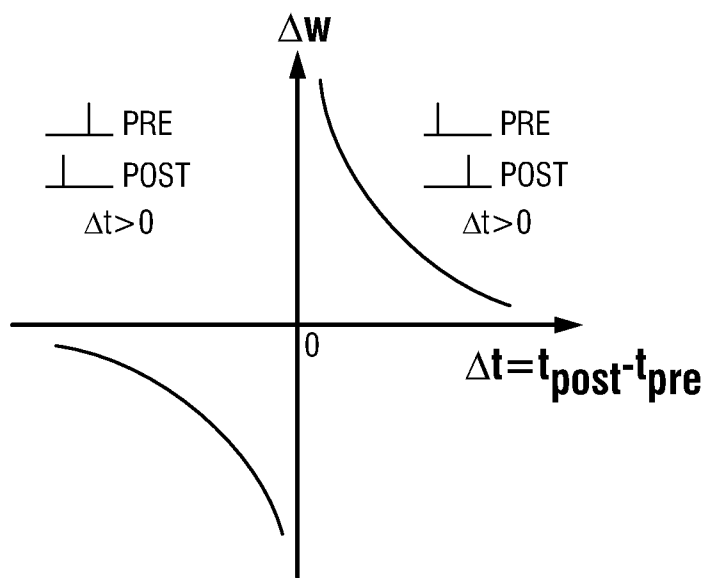


FIG. 6B

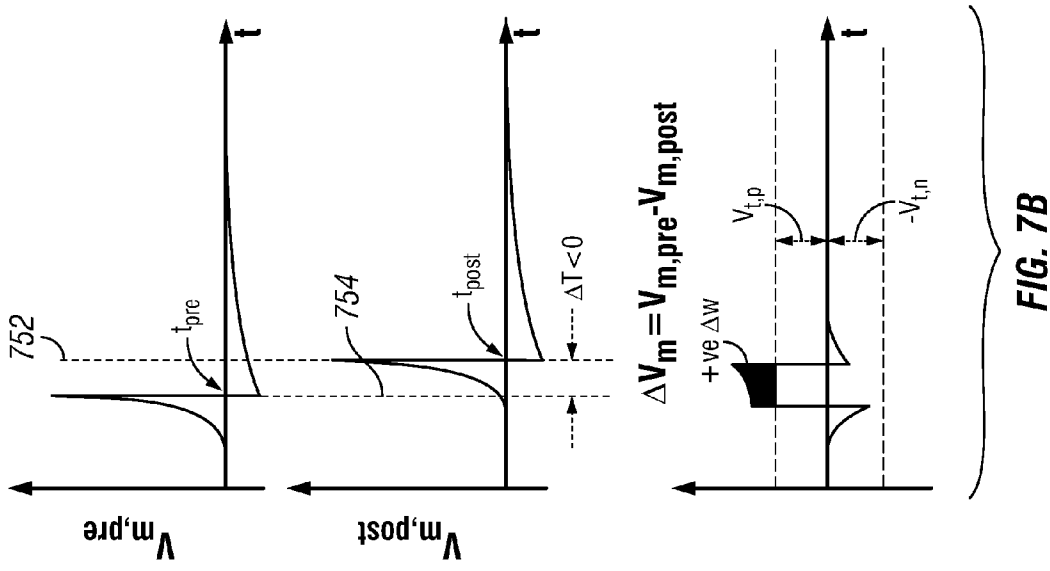


FIG. 7A

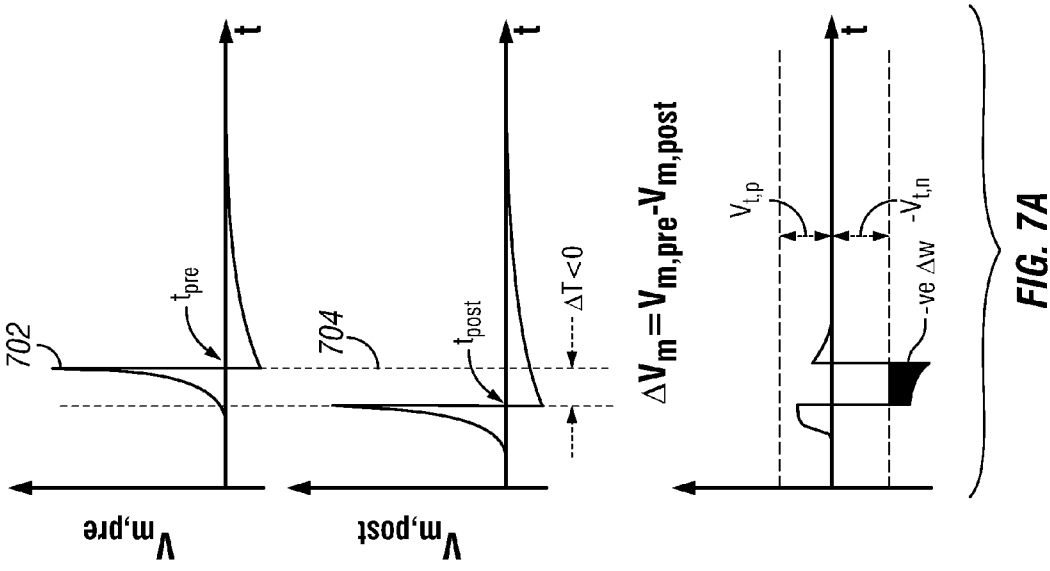
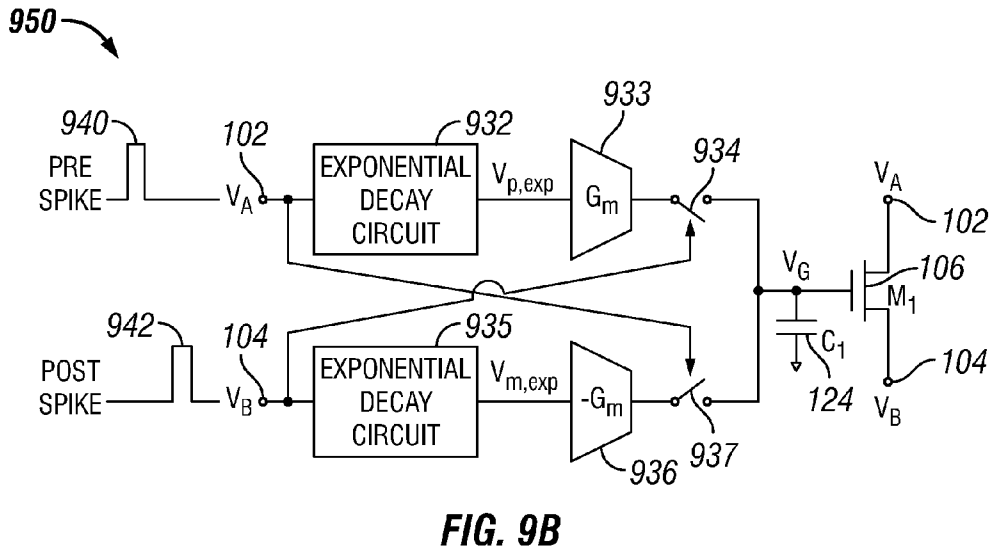
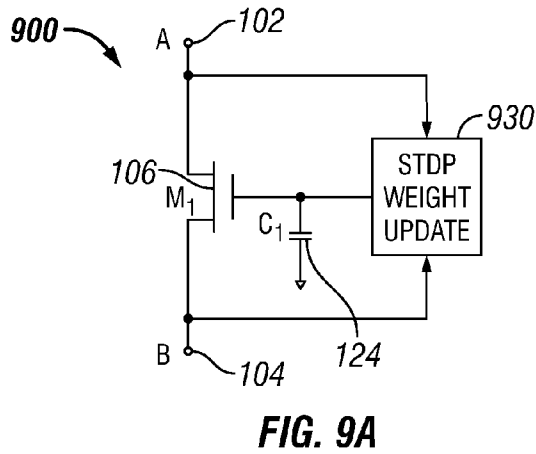
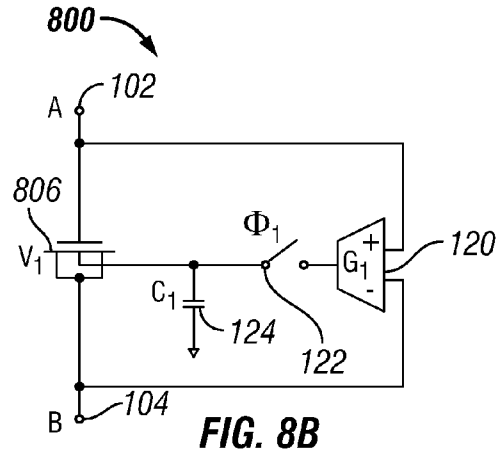
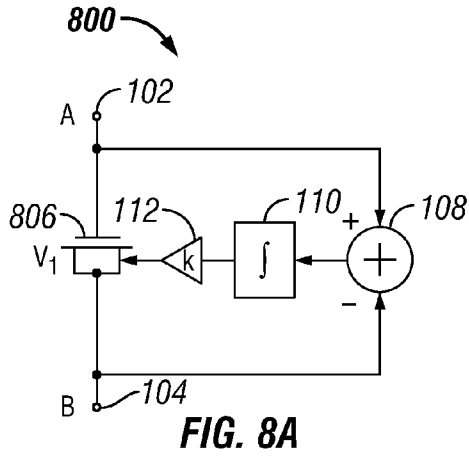


FIG. 7B



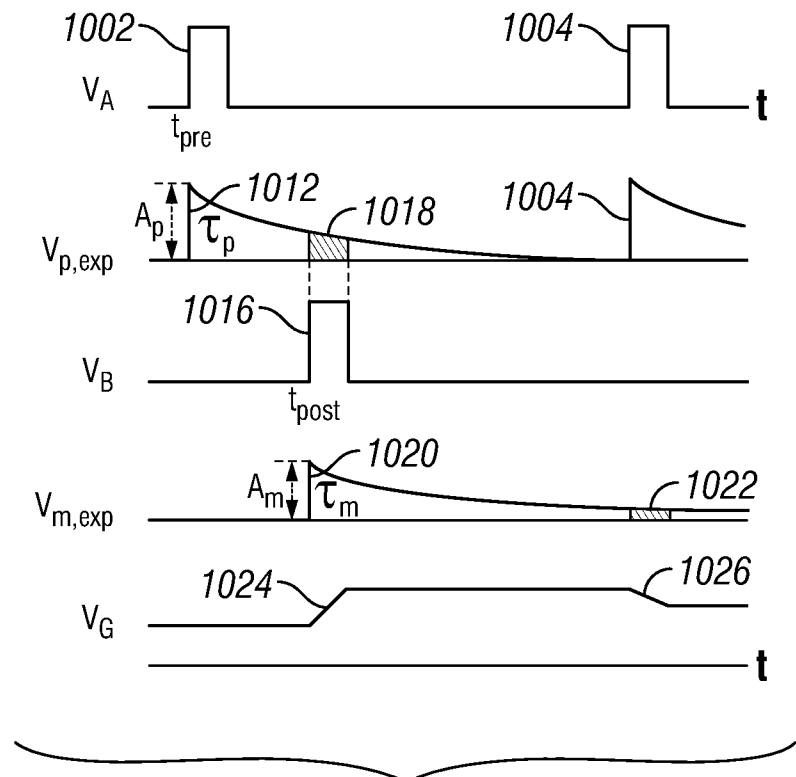


FIG. 10A

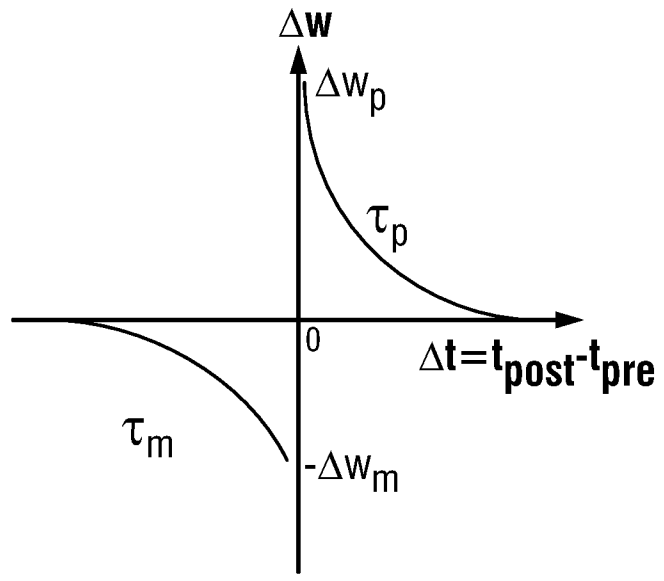


FIG. 10B

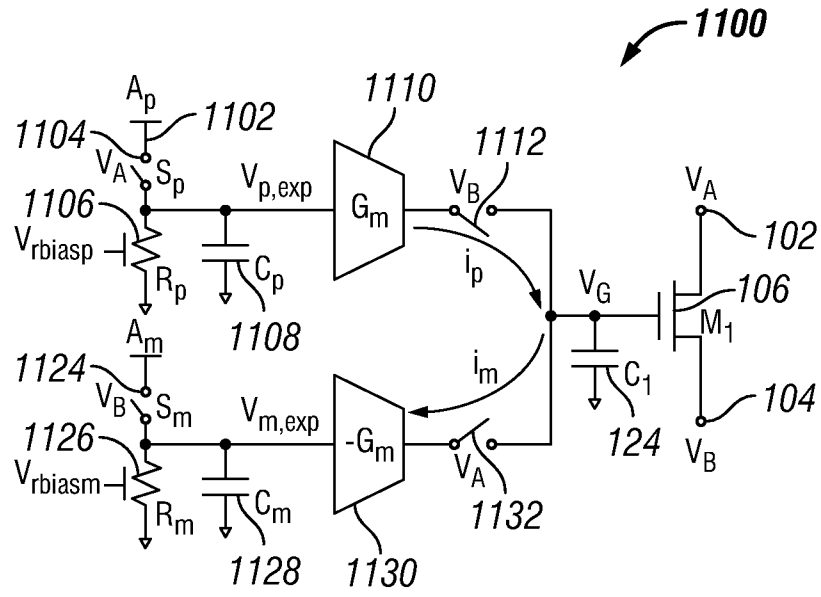


FIG. 11

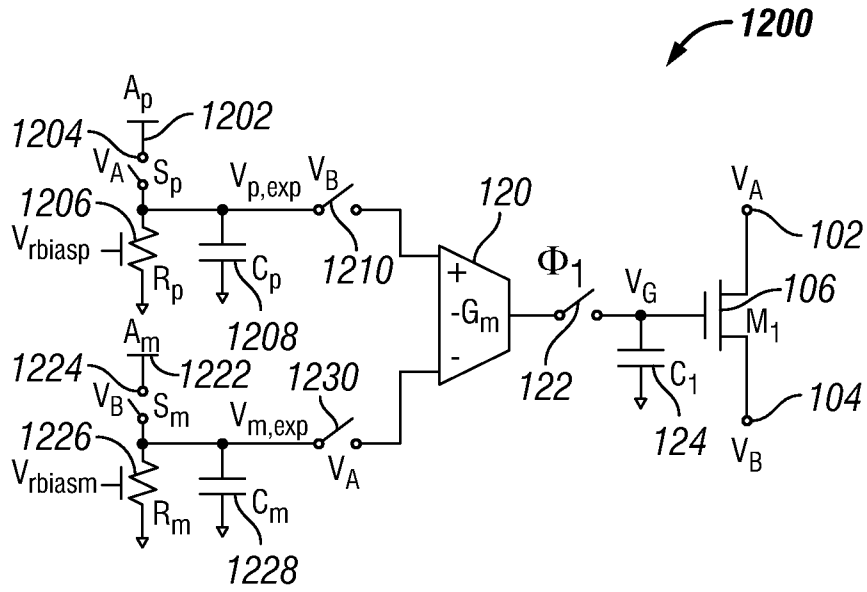


FIG. 12

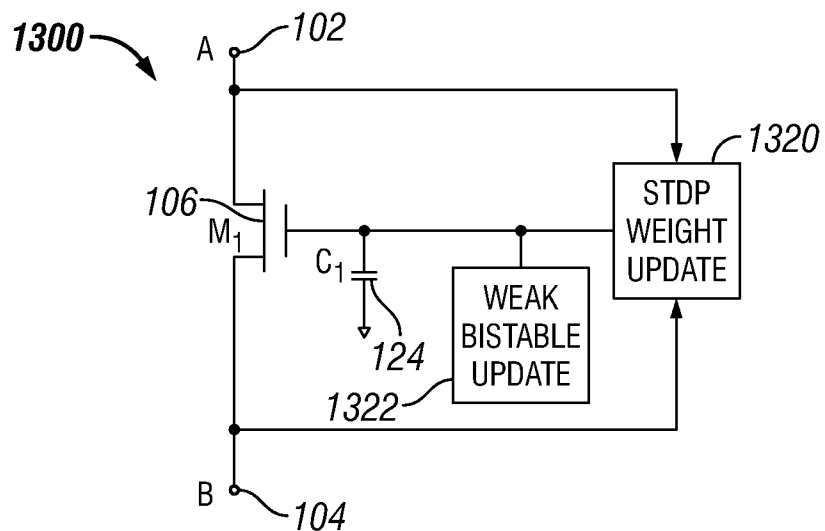


FIG. 13A

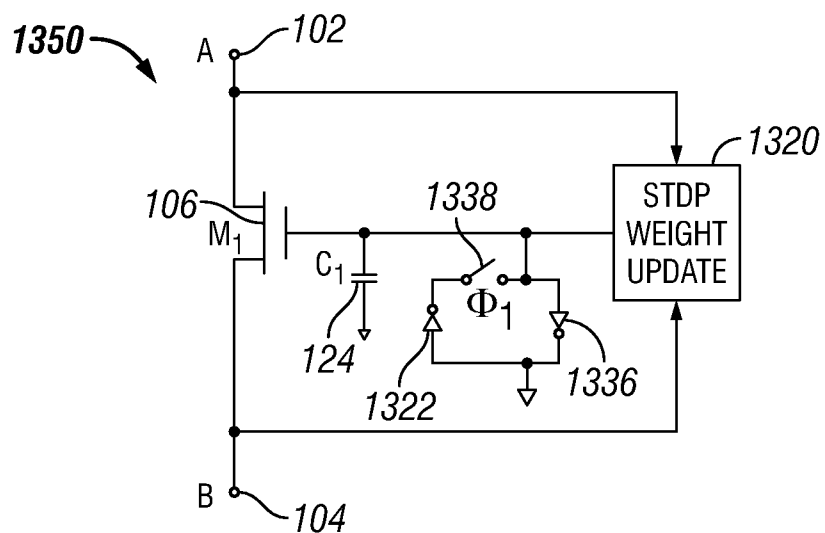


FIG. 13B

MEMORY CONTROLLED CIRCUIT SYSTEM AND APPARATUS

RELATED APPLICATIONS

[0001] This application, under 35 U.S.C. §119, claims the benefit of U.S. Provisional Patent Application Ser. No. 61/973,754 filed on Apr. 1, 2014, and entitled “DYNAMIC SYNAPSE CIRCUITS,” which is hereby incorporated by reference herein.

FIELD OF THE DISCLOSURE

[0002] The present disclosure generally relates to a memory controlled circuit and more particularly to a synapse-type memory controlled circuit.

BACKGROUND

[0003] Computing technology continues to advance by steadily scaling transistor size and by adding more complexity to processing devices while also lowering power consumption in the processing devices. However, as computing technology becomes smaller and more complex, it is increasingly difficult to maintain the current scaling rates. Traditional computer architectures, such as the von-Neumann architecture, require a large number of interconnects and other components. The von-Neumann architecture may be insufficient to keep up with the rapid pace of scaling associated with newer computing devices. For example, current difficulties associated with traditional computer architectures include device variability and interconnect bottlenecks. These difficulties become more pronounced as computing devices become smaller. In order to ensure continued advances in computing technology, new computer architectures are needed to overcome the scaling difficulties associated with traditional computer architectures.

SUMMARY

[0004] Disclosed is a memory controlled circuit that may at least partially emulate a synapse of a biological brain. The memory controlled circuit includes a transistor or another type of configurable circuit to generate a variable resistance or a variable capacitance between two terminals. The transistor or other type of configurable circuit may be controlled by a state of the memory controlled circuit. The memory controlled circuit may further include a capacitor or other dynamic analog memory to store the state.

[0005] In an embodiment, a memory controlled circuit includes a configurable circuit element electrically coupled to a first terminal and to a second terminal. The memory controlled circuit further includes a weight update circuit. A first input of the weight update circuit is electrically coupled to the first terminal and a second input of the weight update circuit is electrically coupled to the second terminal. The memory controlled circuit also includes a dynamic analog memory electrically coupled to the configurable circuit element and to the weight update circuit.

[0006] In an embodiment, the weight update circuit includes a first exponential decay circuit, an input of the first exponential decay circuit coupled to the first terminal. The weight update circuit may also include a first switch. An input of the first switch may be coupled to an output of the first exponential decay circuit and an output of the first switch may be coupled to the dynamic analog memory. A controller of the first switch may be coupled to the second terminal. The

weight update circuit may also include a second exponential decay circuit, an input of the second exponential decay circuit coupled to the second terminal. The weight update circuit may include a second switch. An input of the second switch may be coupled to an output of the second exponential decay circuit and an output of the second switch may be coupled to the dynamic analog memory. A controller of the second switch may be coupled to the first terminal.

[0007] In an embodiment, the first exponential decay circuit includes a resistor. The first exponential decay circuit may further include a capacitor coupled to the resistor. The first exponential circuit may also include a third switch coupled to a voltage source. A level of the voltage source may correspond to a peak spike level. A controller of the third switch may be coupled to the first terminal. The third switch may enable a voltage at the capacitor to charge to the peak spike level when activated. The voltage may dissipate through the resistor when the third switch is disabled. The resistor may include a transistor coupled with a biasing circuit. The biasing circuit may cause the transistor to generate a resistance.

[0008] In an embodiment, the second exponential decay circuit includes a second resistor. The second exponential decay circuit may also include a second capacitor coupled to the second resistor. The second exponential circuit may further include a fourth switch coupled to a second voltage source. A level of the second voltage source may correspond to a second peak spike level. A controller of the fourth switch may be coupled to the second terminal. The fourth switch may enable a voltage at the capacitor to charge to the second peak spike level when activated. The voltage may dissipate through the second resistor when the fourth switch is disabled.

[0009] In an embodiment, the weight update circuit further includes a first transconductor coupled between an output of the first exponential decay circuit and an input of the first switch. The weight update circuit may also include a second transconductor coupled between an output of the second exponential decay circuit and an input of the second switch.

[0010] In an embodiment, the weight update circuit also includes a transconductor, a first input of the transconductor coupled to an output of the first switch and a second input of the transconductor coupled to an output of the second switch. An output of the first exponential decay circuit may be coupled to an input of the first switch and an output of the second exponential decay circuit may be coupled to an input of the second switch.

[0011] In an embodiment, the memory controlled circuit further includes a third switch coupled between the transconductor and the dynamic analog memory. A controller of the third switch may be coupled to a strobe signal source.

[0012] In an embodiment, the memory controlled circuit also includes a bi-stable memory element coupled to the dynamic analog memory. The bi-stable memory element may be configured to stabilize a state of the dynamic analog memory when activated. The bi-stable memory element may include a first inverter. The bi-stable memory element may further include a second inverter. The bi-stable memory element may also include a switch. The first inverter and the second inverter may hold a particular voltage at the capacitor when the switch is activated. The capacitor may discharge when the switch is deactivated.

[0013] In an embodiment, the memory controlled circuit is integrated into a system of memory controlled circuits. The system may include at least one input neuron device. The system may also include at least one output neuron device.

The at least one input neuron device may be coupled to the at least one output neuron device via the first terminal and the second terminal.

[0014] In an embodiment, a method includes receiving a first digital pulse at a first terminal. The method further includes receiving a second digital pulse at a second terminal. The method also includes, in response to the second digital pulse, changing a value of a dynamic analog memory to a modified value. A difference between the value and the modified value may be based on a duration between a first time of the first digital pulse and a second time of the second digital pulse.

[0015] In an embodiment, an electrical property of a configurable circuit element positioned between the first terminal and the second terminal changes based on the modified value of the dynamic analog memory.

[0016] In an embodiment, the method also includes in response to receiving the first digital pulse, generating an exponentially decaying voltage. The method may include generating a current proportionally related to the exponentially decaying voltage. The method may further include electrically coupling the current to the dynamic analog memory during the second digital pulse. The method may also include receiving a third digital pulse at the first terminal. The method may include, in response to the third digital pulse, changing a value of the dynamic analog memory to a second modified value. A difference between the modified value and the second modified value may be based on a duration between the second time of the second digital pulse and a third time of a third digital pulse.

[0017] In an embodiment, the method further includes, in response to receiving the second digital pulse, generating an exponentially decaying voltage. The method may also include generating a current proportionally related to the exponentially decaying voltage. The method may include electrically coupling the current to the dynamic analog memory during the third digital pulse. The method may further include holding a voltage level of the dynamic analog memory at a bi-stable memory element.

[0018] In an embodiment, a method includes receiving a first digital pulse from a first neuron device. The method further includes passing the first digital pulse to a second neuron device. The method also includes receiving a second digital pulse from the second neuron device. The method includes passing the second digital pulse to the first neuron device. The method further includes changing a value of a dynamic analog memory based on the first digital pulse and the second digital pulse.

[0019] In an embodiment, changing the value of the dynamic analog memory includes increasing the value when the first digital pulse is received before the second digital pulse and decreasing the value when the first digital pulse is received after the second digital pulse.

[0020] The method of claim 18, wherein a magnitude of changing the value of the dynamic analog memory is based on a duration between the first digital pulse and the second digital pulse.

[0021] While the disclosure is susceptible to various modifications and alternative forms, specific embodiments have been shown by way of example in the drawings and will be described in detail herein. However, it should be understood that the disclosure is not intended to be limited to the particular forms disclosed. Rather, the intention is to cover all modifications, equivalents and alternatives, both structural and

operational, falling within the spirit and scope of the disclosure as defined by the appended claims.

BRIEF DESCRIPTION OF THE DRAWINGS

[0022] FIG. 1A illustrates a conceptual block diagram for an embodiment of a synapse-type memory controlled circuit;

[0023] FIG. 1B illustrates a circuit implementation of an embodiment of a synapse-type memory controlled circuit;

[0024] FIG. 2A illustrates a current-voltage hysteresis curve for a simulated embodiment of a synapse-type memory controlled circuit;

[0025] FIG. 2B illustrates a state trajectory for the simulated embodiment of the synapse-type memory controlled circuit when swept with a sine-wave input at 1 MHz frequency;

[0026] FIG. 3 illustrates a pulsed characterization response of the simulated embodiment of the synapse-type memory controlled circuit showing monotonic incremental state control;

[0027] FIG. 4 illustrates an embodiment of a synapse-type memory controlled circuit with asynchronous weight update, compatible with spike timing-dependent plasticity (STDP) learning mechanisms.

[0028] FIGS. 5A-5B illustrate embodiments of a synapse-type memory controlled circuit with asynchronous weight update using an embodiment of an event detector, compatible with STDP learning mechanisms.

[0029] FIGS. 6A-6B illustrate an example of an STDP learning mechanism in a bio-inspired synapse-type memory controlled circuit.

[0030] FIGS. 7A-7B illustrate an example of STDP-type synaptic weight updates that depend on the relative timing of the pre- and post-synaptic action potentials.

[0031] FIG. 8A illustrates a conceptual block diagram of an embodiment of a synapse-type memory controlled circuit.

[0032] FIG. 8B illustrates a circuit implementation of an embodiment of a synapse-type memory controlled circuit.

[0033] FIGS. 9A-9B illustrate embodiments of a synapse-type memory controlled circuit compatible with digital spikes.

[0034] FIG. 10A illustrates characteristic timing and waveforms of an embodiment of a synapse-type memory controlled circuit using digital spikes.

[0035] FIG. 10B illustrates an STDP learning function exhibited by an embodiment of a synapse-type memory controlled circuit using digital spikes.

[0036] FIG. 11 illustrates an embodiment of a synapse-type memory controlled circuit with an exponential decay circuit.

[0037] FIG. 12 illustrates an embodiment of a synapse-type memory controlled circuit with an exponential decay circuit.

[0038] FIGS. 13A-13B illustrate embodiments of a bi-stable synapse-type memory controlled circuit.

[0039] FIG. 14 illustrates an embodiment of a system 800 memory controlled circuits with a store and refresh scheme using an ADC/DAC combination.

DETAILED DESCRIPTION

[0040] Referring to FIG. 1A, a conceptual block diagram of an embodiment of a synapse-type memory controlled circuit 100 is depicted. The memory controlled circuit 100 includes a first terminal 102, a second terminal 104, and a configurable circuit element 106 coupled to the first terminal 102 and to the second terminal 104. The functionality of the memory con-

trolled circuit 100 is depicted conceptually by a voltage difference sensing phase 108, an integration phase 110, and a gain control phase 112, as described herein.

[0041] The configurable circuit element 106 may include a transistor. For example, as shown in FIG. 1A, a transistor M1 may be coupled between the first terminal 102 and the second terminal 104. A drain of the transistor M1 may be coupled to the first terminal and a source of the transistor M1 may be coupled to the second terminal 104. Alternatively, the source of the transistor M1 may be coupled to the first terminal 102 and the drain of the transistor M1 may be coupled to the second terminal 104. The transistor M1 may be configured to operate in a linear (e.g., triode) or near-linear operating mode. For example, the transistor M1 may be a zero threshold voltage transistor to enable the transistor M1 to operate in a linear or near linear mode for large signal excursions. Operating the transistor M1 in a linear or near linear mode enables the memory controlled circuit 100 to exhibit variable resistance between the first terminal 102 and the second terminal 104, as controlled by a gate voltage of the transistor M1.

[0042] Although FIG. 1A depicts the configurable circuit element 106 as a type of field effect transistor (FET), in other embodiments, the configurable circuit element 106 may be any type of three-terminal switch. For example, the configurable circuit element 106 may be an N-channel field effect transistor (FET), a P-channel FET, an NPN bipolar junction transistor (BJT), a PNP BJT, a junction gate field-effect transistor (JFET), or another type of three-terminal switch. In one embodiment the three-terminal switch includes a variable capacitor, as described further with reference to FIGS. 7A and 7B.

[0043] During operation, a voltage difference V_{AB} between the first terminal 102 and the second terminal 104 may be sensed as represented by the voltage difference sensing phase 108. During the integration phase 110, the voltage difference may be integrated over time. To illustrate, a value (or a “state” in terms of a synapse) stored at a dynamic analog memory may be increased or decreased based on an integration operation performed on the voltage difference V_{AB} over time. For example, the dynamic analog memory may include a capacitor, and the value (or state) may include a charge stored at the capacitor, as described further with reference to FIG. 1B. The charge may be increased when the voltage difference V_{AB} exceeds a positive threshold and decreased when the voltage difference falls below a negative threshold. A particular embodiment of the implementation of the integration phase 110 and the dynamic analog memory are further described with reference to FIG. 1B.

[0044] At the gain control phase 112, the value of the dynamic analog memory may be used to configure the configurable circuit element 106. For example, an electrical property of the configurable circuit element 106 may be changed based on the value. To illustrate, in embodiments where the configurable circuit element 106 includes the transistor M1, the value of the dynamic analog memory may be used to generate a gate voltage at the transistor M1. A resistance between the drain and the source of the transistor M1 (and also between the first terminal 102 and the second terminal 104) may be changed based on changes to the gate voltage. For example, depending on the particular implementation, an increase in the gate voltage may result in a decrease in resistance between the drain and the source and a decrease in the gate voltage may result in an increase in resistance between the drain and the source.

[0045] The synapse-type memory controlled circuit 100 may provide a floating variable resistance between the first terminal 102 and the second terminal 104 controlled by a memory element (e.g., the dynamic analog memory). If a positive voltage is applied across the memory controlled circuit (if a voltage at the first terminal 102 is greater than a voltage at the second terminal 104) then the gate voltage is increased. The increase in the gate voltage may result in a decrease of resistance between the first terminal 102 and the second terminal 104. Hence, the synapse-type memory controlled circuit 100 is “programmed.” Similarly, if a negative voltage is applied across the memory controlled circuit (if a voltage at the first terminal 102 is less than a voltage at the second terminal 104) then the gate voltage is decreased. The decrease in gate voltage may result in an increase of resistance between the first terminal 102 and the second terminal 104. Hence the synapse-type memory controlled circuit 100 is “erased.” As such, the synapse-type memory controlled circuit 100 may exhibit the dynamic functionality of a fourth fundamental circuit element (i.e., in addition to a resistor, a capacitor, and an inductor) called a “memristor”. The synapse-type memory controlled circuit 100 may further substantially mimic a wide variety of biological synapses found in animal brain and neuro-muscular system, and may be used in conjunction with biologically compatible plasticity learning rules including spike-timing dependent plasticity (STDP), anti-STDP, and Hebbian-type learning.

[0046] Referring to FIG. 1B, a circuit implementation of an embodiment of the synapse-type memory controlled circuit 100 is depicted. The memory controlled circuit 100 may include a transconductor 120, a switch 122, and a dynamic analog memory, such as a capacitor 124. The transconductor 120, the switch 122, and the capacitor 124 may realize the functionality described with reference to FIG. 1A. For example, the transconductor 120, the switch 122, and the capacitor 124 may each perform portions of operations corresponding to the voltage difference sensing phase 108, the integration control phase 110, and the gain control phase 112, of FIG. 1A, as described herein.

[0047] In the embodiment depicted in FIG. 1B, the transconductor 120 may be configured to sense a voltage difference between the first terminal 102 and the second terminal 104 and to generate a current based on the voltage difference. For example, the transconductor 120 may include a circuit that implements a voltage controlled current source (VCCS). The VCCS may include an operational transconductor amplifier (OTA), a differential amplifier, a single-ended transconductor, or another type of transconductor circuit. The transconductor 120 may be further configured to transmit the generated current to the switch 122.

[0048] The switch 122 may be coupled to an output of the transconductor 120 and to the capacitor 124. The position of the switch 122 within the synapse-type memory controlled circuit 100 may enable the switch 122 to electrically connect the transconductor 120 to the capacitor 124 and to electrically disconnect the transconductor 120 from the capacitor 124 based on an external strobe $\Phi 1$ received at the switch 122. For example, when the external strobe $\Phi 1$ is a logical high, the switch 122 may be configured to electrically couple an output of the transconductor 120 to the capacitor 124. When the external strobe $\Phi 1$ is a logical low, the switch 122 may be configured to electrically uncouple the output of the transconductor 120 from the dynamic analog memory 124.

[0049] The capacitor **124** may be coupled to an output of the switch **122** and to an input of the configurable circuit element **106**. The input of the configurable circuit element **106** may be a control input of the configurable circuit element **106**. For example, in embodiments where the configurable circuit element **106** includes the transistor **M1**, the control input may correspond to a gate of the transistor **M1**. The capacitor may also be coupled to a common voltage (e.g., a ground voltage) to enable the capacitor to store a charge at the input of the configurable circuit element **106**. The charge may be used to store a value (or state) of the synapse-type memory controlled circuit **100**. The value may control an electrical property of the configurable circuit element **106**. For example, in the embodiment shown in FIG. **1B**, the value may control a resistance of the configurable circuit element **106**.

[0050] The capacitor **124** may include any type of capacitive element. For example, the capacitor **124** may include an N-channel capacitor, a P-channel capacitor, a MOSCAP poly-poly capacitor, a reversed biased diode, or another type of capacitive element. In one embodiment, a capacitance value of the capacitor is between about 100 femtofarads to five picofarads when implemented on a complementary metallic oxide semiconductor (CMOS) chip. Although FIG. **1B** depicts the dynamic analog memory as being the capacitor **124**, in other embodiments, the dynamic analog memory may include other types of memory usable to store an analog value.

[0051] During operation, the transconductor **120** may sense a voltage difference between the first terminal **102** and the second terminal **104**. Based on the voltage difference, the transconductor **120** may generate a current at an output of the transconductor **120**. The switch **122** may receive the generated current.

[0052] As described above, the switch **122** may be controlled by the external strobe $\Phi 1$. When the strobe $\Phi 1$ is a logical high, the switch **122** may electrically couple the output of the transconductor **120** to the capacitor **124**, thereby enabling the current generated by the transconductor **120** to be applied to the capacitor **124**. The generated current may change a charge at the capacitor **124**. For example, the value of a charge held at the capacitor **124** may be increased or decreased based on the current generated by the transconductor **120**. Applying the generated current to the capacitor **124**, and thereby generating a voltage at the capacitor **124**, may have the effect of integrating the voltage difference sensed by the transconductor **120** over time with an effective gain k . Hence, the current integration phase **108** described with reference to FIG. **1A** may be performed.

[0053] When the external strobe $\Phi 1$ is a logical low, the capacitor **124** may be electrically disconnected from the transconductor **120** and may hold a value (or state) as a stored charge, thus exhibiting the characteristics of the dynamic analog memory.

[0054] For synchronous operations, the external strobe $\Phi 1$ may be provided by a system clock. This configuration may be useful in machine learning applications that synchronously process data. Alternatively, in a bio-inspired spiking neural network (SNN), neurons may fire asynchronously based on sparse spiking input patterns. In an asynchronous application the strobe $\Phi 1$ may be generated using spiking inputs (or “action potentials” in terms of a synapse) applied to the synapse-type memory controlled circuit as described further with reference to FIG. **4**.

[0055] The value of the dynamic analog memory (e.g., the value of the charge stored at the capacitor **124**) may control the configurable circuit element **106**. For example, in embodiments where the configurable circuit element **106** is the transistor **M1**, as illustrated by FIGS. **1A** and **1B**, a voltage stored at the capacitor **124** may control a gate voltage of the transistor **M1**. When the transistor **M1** is operated in a linear or near-linear operating mode, the transistor **M1** may perform the function of a memory controlled variable resistor between the first terminal **102** and the second terminal **104**. For example, the drain-source resistance of the transistor **M1** may be altered by updating the gate voltage in response to voltage pulses applied across the first terminal **102** and the second terminal **104**. If square pulses are used, the incremental update in the gate voltage may be approximately given by

$$\Delta V_G = \frac{G_1}{C_1} V_{pulse} \Delta T$$

[0056] where G_1 , C_1 , V_{pulse} and ΔT are the transconductance of the transconductor **120**, the capacitance of the capacitor **124**, the pulse height, and the pulse width, respectively. If the transistor **M1** is in deep triode (e.g., within the linear operating mode), the current flowing through the synapse-type memory controlled circuit may be approximated by

$$I \approx KP \frac{W}{L} (V_{GS} - V_{THN}) V_{AB}$$

[0057] where V_{GS} and V_{THN} are the gate-to-source and threshold voltages, KP is the transconductance parameter, W is the width and L is the length of the gate of the transistor **M1**, and V_{AB} is the voltage difference between the first terminal **102** and the second terminal **104**. This results in a resistance between the first terminal **102** and the second terminal **104** that may be approximated by

$$R \approx \frac{1}{KP \frac{W}{L} (V_{GS} - V_{THN})}$$

[0058] If the source of the transistor **M1** is pinned at a common-mode voltage V_{CM} , then the conductance G (or the “weight” W in terms of synapses) between the first terminal **102** and the second terminal **104** may be approximated by

$$W \approx KP \frac{W}{L} (V_G - V_{CM} - V_{THN})$$

[0059] which shows a direct relation between the state V_G and the synaptic weight W . Although, the transistor **M1** is described with reference to FIGS. **1A** and **1B** as being in a linear operating mode, as CMOS technology scales, the saturation resistance for FET transistors may be lowered. Thus, the synapse-type memory controlled circuit **100** may exhibit the above described resistance even when the transistor **M1** is in moderate saturation.

[0060] The synapse-type memory controlled circuit **100** of FIGS. **1A** and **1B** realizes a two-terminal variable resistor,

with incremental memory in a feedback loop, whose resistance is controlled by external electrical stimulus applied across the two terminals. The resistance of the synapse-type memory controlled circuit **100** can be altered by applying direct current (DC) or pulsed voltage or current across its terminals. The analog memory element (e.g., the capacitor **124**) stores the state unless changed by application of an external voltage or current, greater than a threshold. The synapse-type memory controlled circuit **100** may also act as a compact emulator for a fourth fundamental circuit element (i.e., in addition to a resistor, a capacitor, and an inductor) called a “memristor.” The synapse-type memory controlled circuit **100** may have application in resistive memory devices (ReRAMs), and may substantially mimic spike-based learning and weight storage functionality of biological synapses found in an animal brain. The synapse-type memory controlled circuit **100** can be designed and fabricated using standard commercial CMOS technologies and may be used for realizing chip-scale circuits for implementing Machine learning algorithms and neurobiology-inspired electronic circuits that may emulate cognitive computing functionality of a biological brain.

[0061] While the transconductor **120**, the switch **122**, and the capacitor **124** may together perform operations corresponding to the voltage difference sensing phase **108**, the integration phase **110**, and the gain control phase **112** of FIG. **1A**, it should be understood that a single component of FIG. **1B** does not necessarily map to a single phase of FIG. **1A**. For example, a combination of multiple components (e.g., the capacitor **124** and the switch **122**) may perform at least a portion of a single phase (e.g., the current integration phase **110**).

[0062] FIGS. **2A**, **2B**, and **3** illustrate various simulation results of an embodiment of a synapse-type memory controlled circuit. The synapse-type memory controlled circuit of FIGS. **2A**, **2B**, and **3** may correspond to the synapse-type memory controlled circuit **100** of FIGS. **1A** and **1B**. For example, the synapse-type memory controlled circuit **100** of FIGS. **1A** and **1B** may exhibit the characteristics described with reference to FIGS. **2A**, **2B**, and **3**.

[0063] Referring to FIG. **2A**, a current-voltage hysteresis curve for a simulated embodiment of a synapse-type memory controlled circuit is depicted. For simulation purposes, the synapse-type memory controlled circuit was designed using a 130 nm CMOS process with a supply voltage of 1.2V, and simulated using foundry device models in Cadence Spectre. The synapse-type memory controlled circuit was swept with a sinusoidal input having a frequency of 1 MHz, an amplitude of 200 mV, and a common-mode DC offset (VCM) of 600 mV, while the strobe $\Phi 1$ was held at a logical high (1.2V). As shown by the current-voltage hysteresis curve, the circuit characteristics of the synapse-type memory controlled circuit exhibit a pinched hysteresis curve typical of a memristor.

[0064] Referring to FIG. **2B**, a state trajectory for the simulated embodiment of the synapse-type memory controlled circuit when swept with a sine-wave input at 1 MHz frequency is depicted. This waveform can be understood as successive voltage sweeps being applied to the synapse-type memory controlled circuit, to trace closely spaced analog memory states. As shown in FIG. **2B**, the circuit characteristics associated with the synapse-type memory controlled circuit exhibit memristor behavior. For example, FIG. **2** demonstrates that the synapse-type memory controlled circuit can hold analog memory states, which can be precisely controlled

by external stimuli. Hence, the simulation corresponding to FIG. **2B** further confirms that the synapse-type memory controlled circuit may function as a memristor.

[0065] Referring to FIG. **3**, a pulsed characterization response of the simulated embodiment of the synapse-type memory controlled circuit showing monotonic incremental state control is depicted. The simulation results depicted in FIG. **3** show that the synapse-type memory controlled circuit exhibits a state retention property. The simulation was performed by applying a pseudorandom sequence with 100 mV pulses ($V_{\text{pulse}}=100$ mV) applied across the terminals of the synapse-type memory controlled circuit every 5 ns ($\Delta T=5$ ns), where a drain of a transistor (corresponding to the transistor **M1** of FIGS. **1A** and **1B**) is tied to a common-mode voltage of 600 mV ($V_{\text{CM}}=600$ mV) with 1 MHz clock rate. FIG. **3** shows that the gate voltage (or state), V_G , is incrementally updated based on a positive or negative pulse input. Since the weight updates of the synapses are monotonic with respect to the applied pulses (or spikes), the synapse-type memory controlled circuit may be used to store analog weights in a machine learning or spiking neural network circuit.

[0066] Referring to FIG. **4**, an embodiment of a synapse-type memory controlled circuit **400** with asynchronous weight update that is compatible with spike timing-dependent plasticity (STDP) learning mechanisms is depicted. The synapse-type memory controlled circuit **400** may correspond to the synapse-type memory controlled circuit **100** described herein. For example, the synapse-type memory controlled circuit **400** may include a first terminal **102**, a second terminal **104**, a configurable circuit element **106**, a transconductor **120**, a switch **122**, and a capacitor **124**. The synapse-type memory controlled circuit **400** may further include a strobe signal source, such as an event detector circuit **402**.

[0067] The event detector circuit **402** may be coupled to the first terminal **102** and the second terminal **104**. For example, a first input of the event detector circuit **402** may be coupled to the first terminal **102** and a second input of the event detector circuit **402** may be coupled to the second terminal **104**. An output of the event detector circuit **402** may be coupled to the switch **122**. The event detector circuit **402** may generate the strobe $\Phi 1$, and may be configured to provide the strobe $\Phi 1$ to the switch **122**.

[0068] During operation, the event detector circuit **402** may asynchronously monitor a voltage difference between the first terminal **102** and the second terminal **104** and may generate the strobe $\Phi 1$ when a particular condition occurs. For example, the strobe $\Phi 1$ may have a logical high value when a voltage difference V_{AB} between the first terminal **102** and the second terminal **104** is greater than an upper threshold or is lower than a lower threshold.

[0069] The functioning of the hysteresis comparator **402** may be compatible with one or more spike dependent plasticity (STDP) learning rules observed in biological synapses, as described further with reference to FIGS. **6A**, **6B**, **7A**, and **7B**. The upper threshold and the lower threshold may be customized depending on a controlling hysteresis of the event detector **402**. Particular embodiments of a synapse-type memory controlled circuit with embodiments of event detectors are described further with reference to FIGS. **5A** and **5B**. Although, the synapse-type memory controlled circuit **400** is depicted in FIG. **4** as including the event detector **402** as the external strobe source, in other embodiments the synapse-

type memory controlled circuit **400** may include a system clock as the external strobe source.

[0070] Referring to FIG. 5A, an embodiment of a synapse-type memory controlled circuit with an embodiment of an event detector is depicted and generally designated **500**. The circuit **500** may include a first terminal **102**, a second terminal **104**, a configurable circuit element **106**, a transistor **120**, a switch **122**, and a capacitor **124**. The circuit **500** may also include an absolute difference circuit **530** and an asynchronous comparator **536**. In some embodiments, the absolute difference circuit **530** and the asynchronous comparator **536** may correspond to the event detector **402**.

[0071] The absolute difference circuit **530** may include a comparator **532** and an absolute value circuit **534**. A first input of the comparator **532** may be coupled to the first terminal **102** and a second input of the comparator **532** may be coupled to the second terminal **104**. An output of the comparator **532** may be coupled to the absolute value circuit **534**.

[0072] The asynchronous comparator **536** may be coupled to the absolute difference circuit **530** at a first input and to a threshold voltage at a second input. The threshold voltage may be determined based on a particular STDP implementation as may be known to persons of ordinary skill in the art having the benefit of this disclosure. An output of the asynchronous comparator **536** may be coupled to the switch **122**.

[0073] During operation, the absolute difference circuit **530** and the asynchronous comparator **536** may generate the strobe $\Phi 1$ based on a voltage difference between the first terminal **102** and the second terminal **104**. For example, the comparator **532** may generate a positive signal or a negative signal related to the voltage difference between the terminals **102**, **104**. The absolute value circuit **534** may receive the positive or negative signal and may perform an absolute value function to generate a signal that represents a magnitude of the voltage difference. The asynchronous comparator **536** may compare the magnitude of the voltage difference to the threshold voltage. In response to the magnitude of the voltage difference exceeding the threshold voltage, the asynchronous comparator **536** may output a logical high signal as the strobe $\Phi 1$.

[0074] Referring to FIG. 5B, an embodiment of a synapse-type memory controlled circuit with an embodiment of an event detector is depicted and generally designated **550**. The circuit **550** may include a first terminal **102**, a second terminal **104**, a configurable circuit element **106**, a transistor **120**, a switch **122**, and a capacitor **124**. The circuit **550** may also include a comparator **540**, a first asynchronous comparator **542**, a second asynchronous comparator **544**, and a logical OR circuit **546**.

[0075] The comparator **540** may correspond to the comparator **532**. An output of the comparator **540** may be coupled to a first input of the first asynchronous comparator **542** and a first input of the second asynchronous comparator **544**. A first threshold voltage may be provided as an input to the first asynchronous comparator **542** and a second threshold voltage may be provided as an input to the second asynchronous comparator **544**. The first threshold voltage may correspond to a positive threshold voltage and the second threshold voltage may correspond to a negative threshold voltage. Outputs of the asynchronous comparators **542**, **544** may be coupled to the logical OR circuit **546**. The logical OR circuit **546** may be coupled to the switch **122**.

[0076] During operation, the comparator **540** may generate a positive signal or a negative signal related to the voltage

difference between the terminals **102**, **104**. The first asynchronous comparator **542** may compare the voltage difference to the first threshold voltage. In response to the voltage difference exceeding the first threshold voltage, the first asynchronous comparator **542** may output a logical high signal. Likewise, the second asynchronous comparator **544** may compare the voltage difference to the second threshold voltage. In response to the voltage difference being less than the second threshold voltage, the second asynchronous comparator **544** may output a logical high signal. In response to a logical high signal from either of the asynchronous comparators **542**, **544**, the logical OR circuit **546** may generate a logical high signal as the strobe $\Phi 1$. It should be noted that in the embodiments depicted in FIGS. 5A and 5B, the voltage difference between the terminals **102**, **104** may be evaluated using either voltage or current mode differencing.

[0077] Referring to FIG. 6A, an example of an STDP learning mechanism in a bio-inspired system **600** is depicted. The system **600** includes a pre-synaptic neuron **602**, a synapse-type memory controlled circuit **604**, and a post-synaptic neuron **606**. The synapse-type memory controlled circuit **604** may correspond to the synapse-type memory controlled circuit **400** of FIG. 4. In particular, the synapse-type memory controlled circuit **604** may include the event detector **402** of FIG. 4, which may be configured to function according to the STDP learning mechanism described herein.

[0078] The pre-synaptic neuron **602** may be coupled to a first terminal of the synapse-like memory controlled circuit **604** to enable a first signal (e.g., a first voltage spike **612**) to be received by the synapse-like memory controlled circuit **604** from the pre-synaptic neuron **602** at the first terminal. Similarly, the post-synaptic neuron **606** may be coupled to a second terminal of the synapse-like memory controlled circuit **604** to enable a second signal (e.g., a second voltage spike **614**) to be received by the synapse-like memory controlled circuit **604** from the post-synaptic neuron **606**.

[0079] During operation, the first voltage spike **612** may be generated by the pre-synaptic neuron and transmitted to the post-synaptic neuron **606** via the synapse-type memory controlled circuit **604**. In response to the first voltage spike **612**, the post-synaptic neuron **606** may generate the second voltage spike **614** and transmit the second voltage spike **614** to the pre-synaptic neuron **602** via the synapse-like memory controlled circuit **604**. Hence, the synapse-type memory controlled circuit **604** enables bi-directional communication between the pre-synaptic neuron **602** and the post-synaptic neuron **606**. The shape of the first voltage spike **612** and the second voltage spike **614** may be determined by a desired implementation of an STDP learning rule. In some embodiments, the second voltage spike **614** is comparable to Ca²⁺-mediated feedback signaling in biological neurons, which effectively update the efficiency (e.g., the weight) of synaptic receptors that bind with neurotransmitters released from synaptic vesicles of a pre-synaptic membrane.

[0080] A weight (e.g., a conductance between the first terminal and the second terminal) of the synapse-type memory controlled circuit **604** may be updated based on the first voltage spike **612** and the second voltage spike **614** as shown in FIG. 6B. For example, an electrical property (e.g., a resistance/conductance) of a configurable circuit element of the synapse-type memory controlled circuit **604** may be changed based on a voltage difference between the first voltage spike **612** and the second voltage spike **614**, as described with reference to FIGS. 1A and 1B. In a particular STDP imple-

mentation, the weight may be updated based on the relative timing of the first voltage spike 612 and the second voltage spike 614. For example, as depicted in FIG. 6B, when the second voltage spike occurs before the first voltage spike ($\Delta t < 0$), a weight change Δw may be negative. Further, when the first voltage spike occurs before the second voltage spike ($\Delta t > 0$), the weight change Δw may be positive. In a particular embodiment, the weight is updated when Δt is within a threshold as described further with reference to FIGS. 7A and 7B.

[0081] Referring to FIGS. 7A and 7B, an example of STDP-type synaptic weight updates that depend on the relative timing of pre- and post-synaptic action potentials is depicted. FIG. 7A illustrates a pre-synaptic action potential 702 being received after a post-synaptic action potential 704, and FIG. 7B illustrates a pre-synaptic action potential 752 being received before a post-synaptic action potential 754. The pre-synaptic action potentials 704, 752 may correspond to the first voltage spike 612 of FIG. 6A and the post-synaptic action potentials 704, 754 may correspond to the second voltage spike 614 of FIG. 6.

[0082] Referring to FIG. 7A, the relative timing of the pre- and post-synaptic action potentials 702, 704 is converted to a potential difference ΔV_m dropped across the synapse-type memory controlled circuit. When ΔV_m exceeds a negative threshold, a weight of the synapse-type memory controlled circuit is decremented by an amount equal to Δw . If a time period between the pre-synaptic action potential 702 and the post-synaptic action potential 704 is too long, then ΔV_m may not exceed the negative threshold and the weight will not be updated.

[0083] Referring to FIG. 7B, the relative timing of the pre- and post-synaptic action potentials 752, 754 is again converted to a potential difference ΔV_m dropped across the synapse-type memory controlled circuit. When ΔV_m exceeds a positive threshold a weight of the synapse-type memory controlled circuit is incremented by an amount equal to Δw . As in FIG. 7A, if a time period between the pre-synaptic action potential 752 and the post-synaptic action potential 754 is too long, then ΔV_m may not exceed the positive threshold and the weight will not be updated.

[0084] The STDP functionality described with reference to FIGS. 6A, 6B, 7A, and 7B may be performed by the synapse-type memory controlled circuit 400 of FIG. 4. Further, the synapse-type memory controlled circuit 400 may be configurable to implement variants of STDP, which may be developed by the Computational Neuroscience community as will be apparent to persons of ordinary skill in the relevant art having the benefit of this disclosure.

[0085] Referring to FIG. 8A, a conceptual block diagram for an embodiment of a synapse-type memory controlled circuit 800 is depicted. The memory controlled circuit 800 may include a first terminal 102 and a second terminal 104. Further, the functionality of the memory controlled circuit 800 may be depicted conceptually by a voltage difference sensing phase 108, an integration phase 110, and a gain control phase 112. The synapse-type memory controlled circuit 800 may include a variable capacitor 806 coupled between the first input 102 and the second input 104. The conceptual operation of the synapse-type memory controlled circuit 800 may be similar to the conceptual operation of the synapse-type memory controlled circuit 100 described herein with the exception that a capacitance (instead of a resistance) between the first terminal 102 and the second terminal 104 may be

controlled based on the voltage difference sensing phase 108, the integration phase 110, and the gain control phase 112.

[0086] Referring to FIG. 8B, a circuit implementation of an embodiment of the synapse-type memory controlled circuit 800 is depicted. The memory controlled circuit 800 may include the transconductor 120, the switch 122, and the dynamic analog memory, such as the capacitor 124. The synapse-type memory controlled circuit 800 may further include the variable capacitor 806 of FIG. 8A. The variable capacitor 806 may be a 3-terminal varactor (V_1), implemented using a MOS capacitor in accumulation or inversion mode. For example, the variable capacitor 806 may be implemented in CMOS technology, with a body or a source/drain of a transistor used as a controller.

[0087] The synapse-type memory controlled circuit 800 may operate in a similar manner as the synapse-type memory controlled circuit 100 described herein. For example, the transconductor 120 may sense a voltage difference between the first terminal 102 and the second terminal 104. Based on the voltage difference, the transconductor 120 may generate a current at an output of the transconductor 120. The switch 122 may receive the generated current. When a strobe $\Phi 1$ is a logical high, the switch 122 may electrically couple the output of the transconductor 120 to the capacitor 124, thereby enabling the current generated by the transconductor 120 to be applied to the capacitor 124. The generated current may change a charge at the capacitor 124. When the strobe $\Phi 1$ is a logical low, the capacitor 124 may be electrically disconnected from the transconductor 120 and may hold a value (or state) as a stored charge, thus exhibiting the characteristics of the dynamic analog memory. The value of the dynamic analog memory (e.g., the value of the charge stored at the capacitor 124) may control the variable capacitor 806. For example, a voltage stored at the capacitor 124 may be used to increase or decrease a capacitance of the variable capacitor 806.

[0088] The synapse-type memory controlled circuit 800 of FIGS. 8A and 8B may extend the memristor concept to a memcapacitor. The memcapacitor may be used as a capacitive synapse-type memory controlled circuit in a spiking neural network. When used in machine learning and neural network circuits, a capacitive synapse-type memory controlled circuit may result lower power consumption as compared to resistive synapse-type memory controlled circuits.

[0089] To realize large-scale neural inspired computing on silicon integrated circuits, the synaptic spikes described herein may include digital pulses instead of the analog-like action potentials with exponential tails as depicted in FIGS. 7A and 7B. Referring to FIG. 9A, an embodiment of a synapse-type memory controlled circuit compatible with digital spikes is depicted and generally designated 900. Like the embodiment described with reference to FIG. 1B, the synapse-type memory controlled circuit 900 may include a first terminal 102, a second terminal 104, a configurable circuit element 106, and a capacitor 124. The circuit 900 may also include an STDP weight update circuit 930.

[0090] The STDP weight update circuit 930 may sense digital pulses occurring at the terminals 102, 104, and may convert their relative timing into a change in a weight of the synapse-like memory controlled circuit 900. For example, the STDP weight update circuit 930 may change a voltage across the capacitor 124 based on the relative timing.

[0091] Referring to FIG. 9B, an embodiment of a synapse-type memory controlled circuit compatible with digital spikes is depicted and generally designated 950. The synapse-type

memory controlled circuit **950** may include a first exponential decay circuit **932**, a first transistor **933**, a first switch **934**, a second exponential decay circuit **935**, a second transistor **936**, and a second switch **937**. The exponential decay circuits **932**, **935**, the transistors **933**, **936**, and the switches **934**, **937** may correspond to the STDP weight update circuit **930**.

[0092] The first exponential decay circuit **932** may be electrically coupled between the first terminal **102** and the first transistor **933**. An input of the first transistor **933** may be coupled to the first exponential decay circuit **932** and an output of the first transistor **933** may be coupled to the first switch **934**. Likewise, the second exponential decay circuit **935** may be coupled between the second terminal **104** and the second transistor **936**. An input of the second transistor **936** may be coupled to the second exponential decay circuit **935** and an output of the second transistor **936** may be coupled to the second switch **937**. The first switch **934** may be controlled by a voltage at the second terminal **104** and the second switch **937** may be controlled by a voltage at the first terminal **102**. For example, a digital voltage pulse at the second terminal **104** may cause the first switch **934** to electrically couple an output of the first transistor **933** to the capacitor **124** and the configurable circuit element **106**. Similarly, a digital voltage pulse at the first terminal **102** may cause the second switch **937** to electrically couple an output of the second transistor **936** to the capacitor **124** and the configurable circuit element **106**.

[0093] During operation, a first digital pulse **940** (e.g., corresponding to a pre-synaptic spike) may be received at the first terminal **102**. The first digital pulse may be shortly followed by a second digital pulse **942** (e.g., corresponding to a post-synaptic spike). In response to the first digital pulse **940**, the first exponential decay circuit **932** may generate an exponentially decaying response voltage that gradually decays over a period of time. The first transistor **933** may generate a current based on the exponentially decaying response voltage. When the second digital pulse **942** is received at the second terminal **104**, the first switch **934** may connect the generated current to the capacitor **124**, thereby changing a voltage level at the capacitor **124**. In an embodiment, the first transistor **933** generates a positive current that increases a voltage across the capacitor **124**, thereby updating a weight of the synapse-type memory controlled circuit **950**.

[0094] In response to the second digital pulse **942**, the second exponential decay circuit **935** may generate a second exponentially decaying response voltage that gradually decays over a period of time. The second transistor **936** may generate a second current based on the second exponentially decaying response voltage. When another digital pulse is received at the first terminal **102**, the second switch **937** may connect the generated current to the capacitor **124**, thereby changing a voltage of the capacitor and updating the weight of the synapse-type memory controlled circuit **950**. In an embodiment, the second transistor **937** generates a negative current that decreases a voltage across the capacitor **124**.

[0095] A benefit of the embodiment of FIGS. **9A** and **9B**, is that STDP weight updates may be performed in response to digital pulses as opposed to systems that do not include the exponential decay circuits **932**, **935**. Hence, the synapse-type memory circuits **900**, **950** may be incorporated into digital integrated circuits. Other advantages and benefits of the cir-

cuits **900** and **950** will be apparent to persons of ordinary skill in the related art having the benefit of this disclosure.

[0096] Referring to FIG. **10A**, characteristic timing and waveforms of an embodiment of a synapse-type memory controlled circuit using digital spikes, as described herein, are depicted. The characteristic timing and waveforms may correspond to the embodiments of FIGS. **9A** and **9B**. As depicted in FIG. **10A**, a first waveform may correspond to a voltage V_A at a first terminal (e.g., the terminal **102**). A second waveform may correspond to a voltage $V_{p,exp}$ corresponding to an exponentially decaying voltage generated by a first exponential decay circuit (e.g., the first exponential decay circuit **932**). A third waveform may correspond to a voltage V_B at a second terminal (e.g., the second terminal **104**). A fourth waveform may correspond to a voltage $V_{m,exp}$ corresponding to an exponentially decaying voltage generated by a second exponential decay circuit (e.g., the second exponential decay circuit **935**). A fifth waveform V_G may correspond to a charge held by a capacitor (e.g., the capacitor **124**) and applied to a controller (e.g., a gate) of the configurable circuit element **106**.

[0097] The first waveform may include a voltage pulse **1002** (corresponding to a pre-synaptic pulse) at a time t_{pre} . In response to the voltage pulse **1002**, the second waveform may include a voltage spike **1012** followed by an exponentially decaying voltage response with an amplitude of A_p and a time constant τ_p . The exponentially decaying spike may be sampled (e.g., by actuating the switch **934**) during a voltage pulse **1016** of the third waveform. In response to the sampling, a voltage increase **1024** may occur at the fifth waveform. For example, the exponentially decaying voltage response may be converted to a positive current by a transistor (e.g., the transistor **933**) and integrated onto a capacitor (e.g., the capacitor **124**) via a switch (e.g. the switch **934**). The voltage increase **1024** may be proportional to the voltage level $V_{p,exp}$ integrated over the duration of the voltage pulse **1002** (e.g., the area **1018** under the curve $V_{p,exp}$).

[0098] In a similar manner, the voltage pulse **1016** may cause a voltage spike **1020** followed by an exponentially decaying voltage response in the fourth waveform with an amplitude A_m and a time constant τ_p . The exponentially decaying voltage response may be sampled (e.g., by actuating the switch **937**) during a voltage pulse **1004** in the first waveform. In response to the sampling, a voltage decrease **1026** may occur at the fifth waveform. For example, the exponentially decaying voltage response may be converted to a negative current by a transistor (e.g., the transistor **935**) and integrated onto the capacitor (e.g., the capacitor **124**) via a switch (e.g., the switch **937**). The voltage decrease **1026** may be proportional to the voltage level $V_{m,exp}$ integrated over the duration of the voltage pulse **1004** (e.g., the area **1022** under the curve $V_{m,exp}$). Thus, the weight corresponding to the synapse-type memory controlled circuit is updated by the relative timing of pre and post digital pulses. Further, in response to the pulse **1004**, the second waveform may include a second voltage spike **1014** followed by a second exponentially decaying voltage response. Hence, the operations described herein may be repeated as additional voltage pulses are received at terminals of a synapse-type memory controlled circuit.

[0099] Referring to FIG. **10B**, an STDP learning function exhibited by the embodiment of FIG. **11A** of a synapse-type memory controlled circuit using digital spikes is depicted. The sampling of exponential decay implements an exponen-

tial STDP learning function to enable fast convergence of spiking neural network learning algorithms. Further, the synaptic potentiation may be given by:

$$\Delta w_p \approx \frac{G_m}{C_1} A_p T_{pulse}$$

[0100] Where G_m is the transconductance of the transconductor 933, C_1 is the capacitance of the capacitor 124, A_p is the amplitude of the decaying voltage spike 1012 and T_{pulse} is the width of the pulse 1002. The synaptic depression may be given by:

$$\Delta w_m \approx -\frac{G_m}{C_1} A_m T_{pulse}$$

[0101] Where G_m is the transconductance of the transconductor 936, C_1 is the capacitance of the capacitor 124, A_m is the amplitude of the decaying voltage spike 1020 and T_{pulse} is the width of the pulse 1016.

[0102] Referring to FIG. 11, an embodiment of a synapse-type memory controlled circuit with an exponential decay circuit is depicted and generally designated 1100. The synapse-type memory controlled circuit 1100 may correspond to the synapse-type memory controlled circuit 9B. For example, the circuit 1100 may include terminals 102, 104, a configurable circuit element 106, a capacitor 124, a first switch 1112, a second switch 1132, a first transconductor 1110, and a second transconductor 1130. The first switch 1112 may correspond to the switch 934 and the second switch 1132 may correspond to the switch 937. Also, the first transconductor 1110 may correspond to the first transconductor 933 and the second transconductor 1130 may correspond to the second transconductor 936.

[0103] The circuit 1100 may further include a first voltage source 1102, third switch 1104, a first resistor 1106, and a capacitor 1108. The first voltage source 1102, the third switch 1104, the first resistor 1106, and the capacitor 1108 may correspond to the first exponential decay circuit 932. The circuit 1100 may further include a second voltage source 1122, a fourth switch 1124, a second resistor 1126, and a capacitor 1128. The fourth switch 1124, the second resistor 1126, and the capacitor 1128 may correspond to the second exponential decay circuit 935. Hence, the exponential decaying responses may be implemented using capacitor charge and discharge circuits.

[0104] The first voltage source 1102 may correspond to a voltage level of a peak spike level. For example, referring to FIG. 10A, the peak spike voltage level may correspond to the voltage A_p at time t_{pre} . Likewise, the second voltage source 1122 may correspond to a second peak spike level such as the voltage A_B at time t_{post} .

[0105] The third switch 1104 may be controlled by a voltage at the first terminal 102. For example, a controller of the third switch 1104 may be coupled to the first terminal 102. The third switch 1104 may enable voltage at the capacitor 1108 to charge to the peak spike level when activated. To illustrate, when activated, the third switch 1104 may couple the capacitor 1108 to the first voltage source 1102, thereby charging the capacitor 1108. When the third switch 1104 is disabled or deactivated, the voltage at the capacitor 1108 may

dissipate through the resistor 1106. Similarly, the fourth switch 1124 may be controlled by a voltage at the second terminal 104. The fourth switch 1124 may enable voltage at the capacitor 1128 to charge to the second peak spike level when activated and may enable the capacitor 1128 to discharge through the second resistor 1126 when deactivated.

[0106] In an embodiment, the first and second resistors 1106, 1126 include transistors coupled with biasing circuits. The transistors may be biased to function in the triode region using voltage references V_{rbiasp} and V_{rbiasm} . Because the transistors are biased to place them in the triode region, the biasing circuit may cause the transistors to generate a resistance, thereby forming a first resistor 1106 and a second resistor 1126.

[0107] During operation, the terminal 102 may receive a first digital pulse (e.g., a pre-synaptic pulse). In response to the first digital pulse, the third switch 1104 may activate, causing the capacitor 1108 to charge to a voltage level corresponding to the voltage A_p . When the first digital pulse terminates, the capacitor 1108 may discharge through the resistor 1106 with a time constant $\tau_p = R_p C_p$, thereby generating a first exponentially decaying voltage $V_{p,exp}$. The exponentially decaying voltage $V_{p,exp}$ may be converted to an exponentially decaying current proportional to the exponentially decaying voltage $V_{p,exp}$ at the transconductor 1110. Thereafter, the terminal 104 may receive a second digital pulse (e.g., a post-synaptic pulse). In response to the second digital pulse, the first switch 1112 may be activated, causing a connection between the transconductor 1110 and the capacitor 124 to be established, thereby altering a charge of the capacitor 124. For example, if the transconductor 1110 generates a positive current, a voltage level of the capacitor 124 may be increased. If the transconductor 1110 generates a negative current, then a voltage level of the capacitor 124 may be decreased. When the second digital pulse terminates, the first switch 1112 may be deactivated.

[0108] Further in response to the second digital pulse, the third switch 1124 may be activated, causing the capacitor 1128 to charge to a voltage level corresponding to the voltage A_M . When the second digital pulse terminates, the capacitor 1128 may discharge through the resistor 1126 with a time constant $\tau_m = R_m C_m$, thereby generating a second exponentially decaying voltage $V_{m,exp}$. The second exponentially decaying voltage $V_{m,exp}$ may be converted to a second exponentially decaying current proportional to the second exponentially decaying voltage $V_{m,exp}$ at the second transconductor 1130. Thereafter, the terminal 102 may receive a third digital pulse. In response to the third digital pulse, the second switch 1132 may be activated, causing a connection between the transconductor 1130 and the capacitor 124 to be established, thereby altering a charge of the capacitor 124. For example, if the transconductor 1130 generates a negative current, a voltage level of the capacitor 124 may be decreased. If the transconductor 1130 generates a positive current, then a voltage level of the capacitor 124 may be increased. When the third digital pulse terminates, the second switch 1132 may be deactivated. Thus, a value of a dynamic analog memory (e.g., the capacitor 124) may be modified. Because the modification of the value of the voltage at the capacitor 124 is based on an exponentially decaying voltage, a difference between an original value of the capacitor 124 and the modified value may be based on a duration between a first time of the first digital pulse and a second time of the second digital pulse or

based on a duration between the second time of the second digital pulse and a third time of the third digital pulse.

[0109] Referring to FIG. 12, an embodiment of a synapse-type memory controlled circuit with an exponential decay circuit is depicted and general designated 1200. The circuit 1200 may include terminals 102, 104, a configurable circuit element 106, a capacitor 124, a first switch 1210, a second switch 1230, a first voltage source 1202, a third switch 1204, a first resistor 1206, a capacitor 1208, a second voltage source 1222, a fourth switch 1224, a second resistor 1226, and a capacitor 1228. The embodiment of FIG. 12 may further include a transconductor 120 and a fifth switch 122.

[0110] An input of the first switch 1210 may be connected to the resistor 1206 and the capacitor 1208. An output of the first switch 1210 may be coupled to a first input of the transconductor 120. When activated, the first switch may connect the resistor 1206 and the capacitor 1208 to the transconductor 120. Likewise, an input of the second switch 1230 may be connected to an output of the resistor 1226 and the capacitor 1228. An output of the second switch 1230 may be connected to a second input of the transconductor 120. When activated, the second switch 1230 may connect the resistor 1226 and the capacitor 1228 to the transconductor 120. An output of the transconductor 120 may be coupled to the fifth switch 122. The fifth switch 122 may be controlled by a strobe signal $\Phi 1$.

[0111] Hence, FIG. 12 depicts an embodiment of a STDP synapse-type memory controlled circuit where two transconductors (e.g., the transconductors 1110, 1130 of FIG. 11) are merged into the transconductor 120. The transconductor 120 may sample the exponentially decaying response voltage $V_{p,exp}$ when the second voltage pulse (e.g., a post-synaptic pulse V_B) is present at the terminal 104. Similarly, the exponentially decaying response $V_{m,exp}$ may be sampled when the first voltage pulse (e.g., a pre-synaptic pulse V_A) is present at the terminal 102. An output current of the transconductor 120 may be integrated into the capacitor 124 in response to the strobe signal $\Phi 1$. In an embodiment, the strobe signal $\Phi 1$ is configured to activate the fifth switch 122 when either the first or second digital pulse are present (e.g., $\Phi 1 = (V_A \text{ OR } V_B)$). In an alternative embodiment, the STDP synapse may not include the fifth switch 122 and alternative means may be used to integrate the current onto the capacitor 124.

[0112] The STDP synapse-type memory controlled circuits disclosed thus far may realize short-term potentiation (e.g., an increase in weight) and depression (e.g., a decrease in weight) where the weights are stored in a capacitive memory that may be subject to leaks. The duration of storage at the dynamic analog memory may depend on the size of the capacitor and leakage associated with the configurable circuit element (e.g., the transistor), and may range from a few seconds to minutes. In some machine learning applications it may be desirable to hold the learned weights for a longer period of time. This can be realized by employing bi-stability in synapses where after short-term STDP learning, the weight is quantized to either a high or low binary state.

[0113] Referring to FIGS. 13A and 13B, embodiments of bi-stable synapse-type memory controlled circuits are depicted. FIG. 13A depicts an embodiment of a bi-stable synapse-type memory controlled circuit 1300 as including terminals 102, 104, a configurable circuit element 106, a capacitor 124, and an STDP weight update circuit 1320. The circuit 1300 also includes a bi-stable memory element 1322 coupled to the capacitor 124.

[0114] The bi-stable memory element 1322 may include a weak bi-stable latch. For example, the bi-stable latch may be designed for large regeneration time-constants such that it doesn't interfere in the short-term STDP learning. Between digital or analog pulses (e.g., STDP pulses) the bi-stable memory element 1322 may steer the state of the synapse-type memory controlled circuit to either increase a voltage (e.g., a high conductance state) or decrease the voltage (e.g., a low conductance state).

[0115] The bi-stable memory element 1322 may be configured to stabilize a state of the capacitor 124 when activated. For example, the bi-stable memory element 1322 may hold a particular voltage (or draw the particular voltage a high or low value) at the capacitor 124 when activated. When deactivated, the bi-stable memory element 1322 may enable the capacitor 124 to discharge.

[0116] FIG. 13B, depicts an embodiment of a bi-stable synapse-type memory controlled circuit 1350 where a first inverter 1332 and a second inverter 1336 are cross-coupled as a binary latch. The inverters 1332, 1336 may include large time-constants resulting in delay times that may prevent the inverters 1332, 1336 from interfering with short term STDP learning (e.g., updating the voltage at the capacitor 124 based on STDP pulses). The large time-constants or inverter delay can be realized by sizing transistors of the inverters 1332, 1336 with large lengths and small widths, and/or starving the current available in the inverters. In an embodiment, a switch 1338 may deactivate the bi-stable memory element 1322 when either pre- or post-synaptic pulses are applied. For example, the bi-stable memory element 1322 may be deactivated in response to a strobe $\Phi 1$. The strobe may be set to a logical high in response to a pulse (e.g., V_A or V_B).

[0117] Referring to FIG. 14, an embodiment of a system 1400 of synapse-type memory controlled circuits with a store and refresh scheme using an ADC/DAC combination is depicted. The system 1400 includes a cross-point array 1410, an array of input neuron devices 1420, an array of output neuron devices 1430, and a store and refresh scheme 1450.

[0118] The cross-point array 1410 may include a plurality of synapse-type memory controlled circuits organized in a cross-point configuration (using rows and columns) to form a dense neural network (ANN or SNN) layer or a machine learning data structure. Each synapse-type memory controlled circuit of cross-point array 1410 may correspond to a synapse-type memory controlled circuit such as the synapse-type memory controlled circuit 100 of FIGS. 1A and 1B, the synapse-type memory controlled circuit 400 of FIG. 4, the synapse-type memory controlled circuit 500 of FIG. 5A, the synapse-type memory controlled circuit 550 of FIG. 5B, the synapse-type memory controlled circuit 900 of FIG. 9A, the synapse-type memory controlled circuit 950 of FIG. 9B, the synapse-type memory controlled circuit 1100 of FIG. 11, the synapse-type memory controlled circuit 1200 of FIG. 12, the synapse-type memory controlled circuit 1300 of FIG. 13A, and/or the synapse-type memory controlled circuit 1350 of FIG. 13B. As a non-limiting example, each synapse-type memory controlled circuit may include a first input 1462, a second input 1464, a configurable circuit element 1466, a transconductor 1470, a switch 1472, and a capacitor 1474. The plurality of synapse-type memory controlled circuits of the cross-point array 1410 may connect the array of input neuron devices 1420 to the array of output neuron devices 1430.

[0119] To illustrate, the array of input neuron devices **1420** may include a first representative input neuron device **1422** and the array of output neuron devices may include a first representative output neuron device **1432**, a second representative output neuron device **1434**, a third representative output neuron device **1436**, and a fourth representative output neuron device **1438**. Further, the cross-point array **1410** may include a first representative synapse-type memory controlled circuit **1412**, a second representative synapse-type memory controlled circuit **1414**, a third representative synapse-type memory controlled circuit **1416**, and a fourth representative synapse-type memory controlled circuit **1418**. The first representative input neuron device **1422** may be connected to each of the representative output neuron devices **1432-1438** via a corresponding synapse-type memory controlled circuit of the representative synapse-type memory controlled circuits **1412-1418**. The number and/or configuration of the input neuron devices, output neuron devices, and synapse-type memory controlled circuits is for illustrative purposes only and may be varied within the scope of the present disclosure as would be appreciated by one of ordinary skill in the art having the benefit of this disclosure.

[0120] The store and refresh scheme **1450** may include an analog-to-digital converter (ADC) **1480**, a digital-to-analog converter (DAC) **1482**, a memory array **1484**, and a controller **1486**. Each synapse-type memory controlled circuit of the cross-point array **1410** may be coupled to the store and refresh scheme **1450**. For example, the ADC **1480** and the DAC **1482** may be coupled to the capacitor **1474** and may enable reading from and writing to the capacitor **1474**. The memory array **1484** may include a long-term memory usable to store states associated with each of the synapse-type memory controlled circuits of the cross-point array **1410**. The controller **1486** may be configured to control the read and write processes of the ADC **1480** and the DAC **1482**.

[0121] During operation, a charge at the capacitor **1474**, if not continually updated, may leak away due to sub-threshold leakage at the switch **1472** as it is controlled by a strobe $\Phi 1$. In order to hold a value (or state) of the synapse-type memory controlled circuit, the value may be periodically read via the ADC **1480** and stored at the memory array **1484**. When needed, the value may be recalled from the memory array **1484** and stored at the capacitor **1474** via the DAC **1482**.

[0122] The system **1400** may operate at very high speeds (up to several GHz), which is beneficial for applications involving big data analytics. Since the system **1400** may be designed using CMOS technology, complicated fabrication steps are not needed to design large neural inspired computing chips. Hence, the system **1400** enables prototype applications targeted for conceptual memristor devices and/or elements. The system **1400** may also synergistically work with memristor devices for fast data processing and non-volatile storage of learned weights in a non-volatile device such as a conducting bridge type memristor, ReRAM, flash memory, and/or phase change memory.

[0123] Although, FIG. **14** depicts the cross-point array **1410** as including 20 synapse-type memory controlled circuits, in other embodiments, the cross-point array **1410** may include more or fewer than 20 synapse-type memory controlled circuits. Further, although FIG. **14** depicts the array of input neuron devices **1420** as including 5 input neuron devices, the array of input neuron devices **1420** may include more or fewer than five input neuron devices. Also, although FIG. **14** depicts the array of output neuron devices **1430** as

including 5 output neuron devices, the array of output neuron devices **1430** may include more or fewer than five output neuron devices. It should be generally understood that the system depicted in FIG. **14** is for purposes of example only and that in other embodiments, the system may include many more input neuron device, output neuron devices, and synapse-type memory controlled circuits than depicted in FIG. **14**.

[0124] Although FIG. **14** depicts each synapse-type memory controlled circuit as including the transistor **1470** and the switch **1472**, in one or more other embodiments the synapse-type memory controlled circuits may correspond to embodiments of the synapse-type memory controlled circuits that do not include the transistor **1470**, and the switch **1472** as described with reference to FIGS. **9A-13B**. Further, in an embodiment, each synapse-type memory controlled circuit is configured to respond to analog STDP pulses as described herein. Alternatively, each synapse-type memory controlled circuit may be configured to respond to digital STDP pulses as described herein. To illustrate, one or more of the embodiments of synapse-type memory controlled circuits (such as the circuit **900**) may be coupled to one or more of the input neuron devices **1420** and to one or more of the output neuron devices **1430**. The synapse-type memory controlled circuit **900** may be configured to receive a first digital pulse from one of the input neuron devices **1420** and to pass the first digital pulse to one of the output neuron devices **1430**. The synapse-type memory controlled circuit **900** may also receive a second digital pulse from one of the output neuron devices **1430** and pass the second digital pulse to one of the input neuron devices **1420**. The synapse-type memory controlled circuit **900** may further change a value of the capacitor **124** based on the first digital pulse and the second digital pulse as described herein. Hence, either an analog synapse-type memory controlled circuit or a digital synapse-type memory controlled circuit may be used in conjunction with the cross-point array **1410**.

[0125] Although various embodiments have been shown and described, the present disclosure is not so limited and will be understood to include all such modifications and variations, both structural and operational, as would be apparent to one skilled in the art.

What is claimed is:

1. A memory controlled circuit comprising:
 - a configurable circuit element electrically coupled to a first terminal and to a second terminal;
 - a weight update circuit, wherein a first input of the weight update circuit is electrically coupled to the first terminal and a second input of the weight update circuit is electrically coupled to the second terminal; and
 - a dynamic analog memory electrically coupled to the configurable circuit element and to the weight update circuit.
2. The memory controlled circuit of claim 1, wherein the weight update circuit comprises:
 - a first exponential decay circuit, an input of the first exponential decay circuit coupled to the first terminal;
 - a first switch, an input of the first switch coupled to an output of the first exponential decay circuit and an output of the first switch coupled to the dynamic analog memory, a controller of the first switch coupled to the second terminal;

- a second exponential decay circuit, an input of the second exponential decay circuit coupled to the second terminal; and
- a second switch, an input of the second switch coupled to an output of the second exponential decay circuit and an output of the second switch coupled to the dynamic analog memory, a controller of the second switch coupled to the first terminal.
- 3.** The memory controlled circuit of claim **2**, wherein the first exponential decay circuit comprises:
- a resistor;
 - a capacitor coupled to the resistor; and
 - an third switch coupled to a voltage source, wherein a level of the voltage source corresponds to a peak spike level, wherein a controller of the third switch is coupled to the first terminal, wherein the third switch enables a voltage at the capacitor to charge to the peak spike level when activated, and wherein the voltage dissipates through the resistor when the third switch is disabled.
- 4.** The memory controlled circuit of claim **3**, wherein the resistor includes a transistor coupled with a biasing circuit, wherein the biasing circuit causes the transistor to generate a resistance.
- 5.** The memory controlled circuit of claim **2**, wherein the second exponential decay circuit comprises:
- a second resistor;
 - a second capacitor coupled to the second resistor; and
 - a fourth switch coupled to a second voltage source, wherein a level of the second voltage source corresponds to a second peak spike level, wherein a controller of the fourth switch is coupled to the second terminal, wherein the fourth switch enables a voltage at the capacitor to charge to the second peak spike level when activated, and wherein the voltage dissipates through the second resistor when the fourth switch is disabled.
- 6.** The memory controlled circuit of claim **2**, wherein the weight update circuit further comprises:
- a first transconductor coupled between an output of the first exponential decay circuit and an input of the first switch; and
 - a second transconductor coupled between an output of the second exponential decay circuit and an input of the second switch.
- 7.** The memory controlled circuit of claim **2**, wherein the weight update circuit further comprises:
- a transconductor, a first input of the transconductor coupled to an output of the first switch and a second input of the transconductor coupled to an output of the second switch,
- wherein an output of the first exponential decay circuit is coupled to an input of the first switch and an output of the second exponential decay circuit is coupled to an input of the second switch.
- 8.** The memory controlled circuit of claim **7**, further comprising:
- a third switch coupled between the transconductor and the dynamic analog memory, a controller of the third switch coupled to a strobe signal source.
- 9.** The memory controlled circuit of claim **1**, further comprising:
- a bi-stable memory element coupled to the dynamic analog memory, the bi-stable memory element configured to stabilize a state of the dynamic analog memory when activated.
- 10.** The memory controlled circuit of claim **9**, wherein the bi-stable memory element comprises:
- a first inverter;
 - a second inverter; and
 - a switch, wherein the first inverter and the second inverter hold a particular voltage at the capacitor when the switch is activated, and wherein the capacitor discharges when the switch is deactivated.
- 11.** The memory controlled circuit of claim **1**, integrated into a system of memory controlled circuits, the system including:
- at least one input neuron device;
 - at least one output neuron device;
- wherein the at least one input neuron device is coupled to the at least one output neuron device via the first terminal and the second terminal.
- 12.** A method comprising:
- receiving a first digital pulse at a first terminal;
 - receiving a second digital pulse at a second terminal;
 - in response to the second digital pulse, changing a value of a dynamic analog memory to a modified value, wherein a difference between the value and the modified value is based on a duration between a first time of the first digital pulse and a second time of the second digital pulse.
- 13.** The method of claim **12**, wherein an electrical property of a configurable circuit element positioned between the first terminal and the second terminal changes based on the modified value of the dynamic analog memory.
- 14.** The method of claim **12**, further comprising:
- in response to receiving the first digital pulse, generating an exponentially decaying voltage; and
 - generating a current proportionally related to the exponentially decaying voltage; and
 - electrically coupling the current to the dynamic analog memory during the second digital pulse.
- 15.** The method of claim **12**, further comprising:
- receiving a third digital pulse at the first terminal; and
 - in response to the third digital pulse, changing a value of the dynamic analog memory to a second modified value, wherein a difference between the modified value and the second modified value is based on a duration between the second time of the second digital pulse and a third time of a third digital pulse.
- 16.** The method of claim **15**, further comprising:
- in response to receiving the second digital pulse, generating an exponentially decaying voltage;
 - generating a current proportionally related to the exponentially decaying voltage; and
 - electrically coupling the current to the dynamic analog memory during the third digital pulse.
- 17.** The method of claim **12**, further comprising holding a voltage level of the dynamic analog memory at a bi-stable memory element.
- 18.** A method comprising:
- receiving a first digital pulse from a first neuron device;
 - passing the first digital pulse to a second neuron device;
 - receiving a second digital pulse from the second neuron device;
 - passing the second digital pulse to the first neuron device;
 - changing a value of a dynamic analog memory based on the first digital pulse and the second digital pulse.
- 19.** The method of claim **18**, wherein changing the value of the dynamic analog memory comprises increasing the value when the first digital pulse is received before the second

digital pulse and decreasing the value when the first digital pulse is received after the second digital pulse.

20. The method of claim **18**, wherein a magnitude of changing the value of the dynamic analog memory is based on a duration between the first digital pulse and the second digital pulse.

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